



LIST OF PRIOR ART CITED BY APPLICANT
(Filed on January 15, 2004)

Docket No. **DSK-ZEI-3214 / 500343.20225**

Applicant(s): **Hans-Juergen DOBSCHAL, Thomas SCHERUEBL, Robert BRUNNER, Norbert ROSENKRANZ and Joern GREIF-WUESTENBECKER**

Application No. **10/626,130**

Group:

Filed: **July 24, 2003**

Examiner:

U.S. PATENT DOCUMENTS

Exam. Init		Document Number	Date	Name	Class	Sub- Class	Filing Date Appropriate
AS	AA	5,022,064	06/04/1991	Ikeaki			
AS	AB	5,131,023	07/14/1992	Yasugaki, et al.			
AS	AC	5,144,497	09/01/1992	Kato, et al.			
AS	AD	5,177,774	01/05/1993	Suckewer, et al.			
AS	AE	5,222,113	06/22/1993	Thieme, et al.			
AS	AF	5,291,339	03/01/1994	Mochimaru, et al.			
AS	AG	5,311,565	05/10/1994	Horikawa			
AS	AH	6,469,827	10/22/2002	Sweatt, et al.			
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	CLASS	Sub- Class	Translation YES	NO
AS	AL	0 459 833	12/04/1991	EP			K/A	
AS	AM	2001-116900	04/27/2001	Japan			Abstract only	
AS	AN	101 30 212	01/02/2003	Germany			Abstract only	
AS	AO	102 20 815	11/20/2003	Germany			Abstract only	
AS	AP	102 20 816	11/20/2003	Germany			Abstract only	
	AQ							
	AR							
	AS							

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AV	
AW	
AX	
AY	
AZ	

Examiner: FAYEZ ASSAF	Date: 6/16/04
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



04-30-04

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I hereby certify that this correspondence is being deposited with the United States Postal Service Express mail under 37 CFR 1.10 on the date indicated above and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Ruth Montalvo / Ruth Montalvo Date: 04/29/04

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No. GK-ZEI-3214 / 500343 20225
Applicant(s): Hans-Juergen DOBSCHAL, et al.
Application No.: 10/626,130 Group:
Filed: July 24, 2003 Examiner:
For: IMAGING SYSTEM FOR A MICROSCOPE BASED ON EXTREME ULTRAVIOLET (EUV) RADIATION

Commissioner of Patents
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Alexandria, VA 22313-1450

SUPPLEMENTAL
INFORMATION DISCLOSURE STATEMENT

SIR:

Supplemental to the Information Disclosure Statement filed on January 15, 2003, enclosed are the following references that were previously omitted:

		Document Number	Date	Name and/or Country	English Translation
<i>noted references have been considered</i>	Re AO	102 20 815	11/20/2003	Germany	English Abstract only
<i>see 1449 received on 1/15/04</i>	Re AP	102 20 816	11/20/2003	Germany	English Abstract only

This submission is not an admission that the information disclosed in the documents is material to the patentability of the invention disclosed and/or claimed in the above-identified application.

Respectfully submitted,

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Enclosures:

PTO-1449

2 documents

2 English Abstract

04/29/04
JGHK:ram

6/14/04